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| ·  | Application No.                                   | Applicant(s)                 |
|--|---|------------------------------|
| Notice of Allowability   | 10/698,143  | TANG ET AL.                  |
|  | Examiner  | Art Unit                     |
|  | Torifur B. Choudhun                               | 2871                         |
|  | Tarifur R. Chowdhury                              | 2071                         |
| The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308. |   |                              |
| 1. X This communication is responsive to <u>amendment filed on 08/30/05</u> .  |   |                              |
| 2. X The allowed claim(s) is/are <u>27-29</u> .  |   |                              |
| <ul> <li>3.</li></ul>  |   |                              |
| 3. Copies of the certified copies of the priority documents have been received in this national stage application from the   |   |                              |
| International Bureau (PCT Rule 17.2(a)).   |   |                              |
| * Certified copies not received:   |   |                              |
| Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.  THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.   |   |                              |
| 4. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.   |   |                              |
| 5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.   |   |                              |
| (a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review ( PTO-948) attached   |   |                              |
| 1)  hereto or 2)  to Paper No./Mail Date   |   |                              |
| (b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of<br>Paper No./Mail Date  |   |                              |
| Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).  |   |                              |
| 6. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.  |   |                              |
|  |   |                              |
| Attachment(s)  1. Notice of References Cited (PTO-892)   | 5. ☐ Notice of Informal P                         | atent Application (PTO-152)  |
| 2.  Notice of Draftperson's Patent Drawing Review (PTO-948)  | 6. Interview Summary                              |                              |
| 3. Information Disclosure Statements (PTO-1449 or PTO/SB/0   | Paper No./Mail Dat<br>08), 7. ☐ Examiner's Amendn |                              |
| Paper No./Mail Date  | 8. X Examiner's Stateme                           | ent of Reasons for Allowance |
| of Biological Material   | 9.  |                              |
|  |   |                              |
|  |   |                              |

Application/Control Number: 10/698,143 Page 2

Art Unit: 2871

## Allowable Subject Matter

1. Claims 27-29 are allowed.

- 2. The following is an examiner's statement of reasons for allowance:
- 3. The prior arts of record do not anticipate or render obvious to one skilled in the art a method for fabricating a reflective type reflector plate of a reflective liquid crystal display, the method comprising several steps as claimed, more specifically, the steps such as forming transparent electrodes over the substrate after the thin film transistors are built on the substrate; depositing a protection layer over the transparent electrode wherein the protection layer shields undesired reflection light during an exposure stage and reduces the exposure time; patterning the transparent electrodes and the protection layer to form pixel patterns; spin coating a photoresist layer over the protection layer using polymer resin material; removing the photoresist layer over non-patterned areas and depositing a reflective metal film over the photoresist layer retained on the glass substrate, are considered novel.

The closest reference US 2003/0058388 discloses a reflective type reflector plate of a reflective liquid crystal display, the plate includes a glass substrate (SUB1) on which thin film transistors (not shown), transparent electrodes (PX1) and undulating resin outgrowth (INTL) are formed, wherein a protection layer (PSV1) is formed between the transparent electrodes and the undulating resin outgrowth. However, the above reference alone or in combination fail to teach or suggest the claimed method for fabricating a reflective type reflector plate of a reflective liquid crystal display.

Application/Control Number: 10/698,143

Art Unit: 2871

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Tarifur R. Chowdhury whose telephone number is (571) 272-2287. The examiner can normally be reached on M-Th (6:30-5:00) Friday Off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert Kim can be reached on (571) 272-2293. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

TRC September 06, 2005

ARIFUR R. CHOWDHURY
PRIMARY EXAMINER